UNITED STATES PATENT AND TRADEMARK OFFICE **CERTIFICATE OF CORRECTION**

PATENT NO.

: 7,098,123 B2

Page 1 of 1

APPLICATION NO.: 10/780244 **DATED**

: August 29, 2006

INVENTOR(S)

: Heo et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On the Title Page:

Add

-- (30) Foreign Application Priority Data

Feb. 19, 2003 (KR)2003-0010403 --

Column 7,

Line 57 should read -- layer comprises tungsten nitride (WN) or titanium nitride (TiN). --

Column 8,

Line 23 should read -- forming a capping layer on the metal gate layer. --

Signed and Sealed this

Ninth Day of January, 2007

JON W. DUDAS Director of the United States Patent and Trademark Office